

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.:

10/594,635

Group Art Unit:

1793

Filing Date:

September 28, 2006

Examiner:

Shuangyi Abu Ali

Applicant:

Yoshiharu OHTA et al.

Title:

SEMICONDUCTOR POLISHING COMPOSITION (As Amended)

Attorney Docket:

2691-000050/US

Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314 Mail Stop AMENDMENT April 30, 2009

REQUEST FOR RECONSIDERATION

Sir:

In response to the Office Action mailed January 30, 2009, the following remarks are respectfully submitted.

A listing of the Claims begin on page 3 of this paper.

Remarks begin on page 5 of this paper.

| | Claims remaining after Amendment | | Highest number previously paid for | | Present extra |
|-------------|----------------------------------|---|------------------------------------|---|---------------|
| Total | 12 | | 20 | = | 0 |
| Independent | 1 | - | 3 | = | 0 |